

**S/N 09/031,326**

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Joseph J. Karniewicz ✓

Examiner: Phan, T.

Serial No.: 09/031,326

Group Art Unit: 2763

Filed: February 26, 1998 ✓

Docket: 303.376US1

Title: PARAMETER POPULATION OF CELLS OF A HIERARCHICAL  
SEMICONDUCTOR STRUCTURE VIA FILE RELATION

**AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111**

Commissioner for Patents  
Washington, D.C. 20231

Applicant has reviewed the Office Action mailed on May 1, 2000. Please amend the above-identified patent application as follows.

**IN THE DRAWINGS**

The Office Action stated that the drawings were objected to under 37 CFR 1.83(a) because they failed to show labels of functional blocks as described in the specification such as in Figs. 1, 3, 4. The Office Action required that any structural detail that is essential for a proper understanding of the disclosed invention should be shown in the drawing and indicated that "Correction is required".

In response to the First Office Action, Applicant submitted copies of Figs. 1-4 of the Application marked to show labels of the functional blocks to be consistent with the remainder of the application and the claims. A copy of those proposed changes is again enclosed herewith. With those proposed changes, Applicant believes that all structural detail necessary for an understanding of the claims is shown in the drawings. To the extent that the Examiner believes that detail additional to that provided in the marked up drawings is needed in the drawings as to any specific element of the claims, Applicant will be pleased to supply it.

**IN THE SPECIFICATION**

The Office Action stated "It is noted that this application appear to claim subject matter disclosed in prior copending Application without including a complete patent application reference number. Also, the current status of all nonprovisional parent applications references should be included". Applicant has submitted herewith a communication concerning copending



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